



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Francois Templier et al. CONFIRMATION NO.: 5812
APP. NO.: 10/526,641 ART UNIT: 2815
FILING DATE: March 2, 2005 EXAMINER: Edward J. Wojciechowicz
TITLE: Quasi-Vertical Power Semiconductor Device on a Composite Substrate

CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on the date printed below:

Date: January 7, 2008

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**Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
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RESPONSE TO OFFICE ACTION

This responds to the Office Action dated July 5, 2007 in the above-referenced patent application. Reconsideration of the application is respectfully request in view of the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

This response is accompanied by a Petition for Extension of Time for a period of three months, up to and including January 7, 2008, and the required fee.